



PATENT
ATTORNEY DOCKET NO. 041514-5103

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Shingo IWASAKI et al. ✓)

Application No.: 09/753,722 ✓)

Filed: January 4, 2001 ✓)

For: ELECTRON-EMITTING DEVICE AND)
METHOD OF MANUFACTURING THE)
SAME AND DISPLAY APPARATUS)
USING THE SAME)

Group Art Unit: 2815

Examiner: B. Baumeister

#12/A
Am dt

Ext. 2 mos

J. McMullen

11/20/02

Commissioner for Patents
Washington, D.C. 20231

Sir:

AMENDMENT

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NOV 18 2002
TECHNOLOGY CENTER 2800

11/21/2002 JMCILLA 00000002 500310 09753722
In response to the Office Action dated June 13, 2002, the period for response to which

01 FC:1202 having been extended through November 13, 2002 by a Petition for Extension of Time and fee

filed concurrently herewith, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claim 1 to read as follows:

1. (Amended) An electron-emitting device comprising:

an electron source layer made of one of a metal, a metal alloy and a semiconductor;

an insulating layer formed on said electron source layer, said insulating layer having at

least one island region serving as an electron-emitting section in which film thickness of said

insulating layer is gradually reduced;

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